



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79889

Yoshitaka NAKAMURA, et al.

Appln. No.: 10/777,704

Group Art Unit: 2812

Confirmation No.: 5693

Examiner: Remmon R. Forde

Filed: February 13, 2004

For: SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREFOR

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

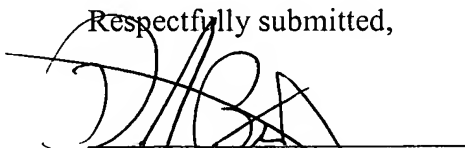
Sir:

In response to the Restriction Requirement, dated February 25, 2005, Applicant elects Group I, claims 1-21 for examination. This election is made without traverse.

Applicant reserves the right to file a Divisional Application directed to non-elected claims 22-48.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,


Howard L. Bernstein
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23373

CUSTOMER NUMBER

Date: March 25, 2005